

IFW

PATENT APPLICATION  
Docket No. 2522-040  
Client No. AW8072US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of: Jae-Jong Han, et al.

Serial No. 10/672,884

Examiner: Lee, Hsien Ming

Confirmation No. 9537

Filed: September 26, 2003

Art Unit: 2823

For: METHOD OF FORMING A GATE ELECTRODE, METHOD OF  
MANUFACTURING A SEMICONDUCTOR DEVICE HAVING  
THE GATE ELECTRODE, AND METHOD OF OXIDIZING A  
SUBSTRATE

Mail Stop AMENDMENT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Responsive to the Office Action dated June 22, 2004, enclosed is an amendment in the above-identified application.

The fee has been calculated as shown below.


CLAIMS AS AMENDED					
For:	Number After Amendment	Previous Number	Extra	Rate	Additional Fee
Total Claims	19	20	0	x \$18 =	\$0
Independent Claims	3	3	0	x \$86 =	\$0
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$0

\*greater of twenty (20) or number for which fee has been paid

\*\*greater of three (3) or number for which fee has been paid

- ☒ Information Disclosure Statement  
☒ PTO form 1449 with 2 cited references  
☒ Any deficiency or overpayment should be charged or credited to deposit account number 13-1703.

Respectfully submitted,  
MARGER JOHNSON & McCOLLOM, P.C.

  
Todd J. Iverson  
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I hereby certify that this correspondence is being  
deposited with the United States Postal Service as  
first class mail in an envelope addressed to: Mail  
Stop Amendment Commissioner for Patents, P.O.  
Box 1450, Alexandria, VA 22313-1450  
Date: September 16, 2004

  
Li Mei Vermilya